

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Francisco Arias et al.

Examiner: Mathieu D Vargot

Serial No.: 10/727,124

Group Art Unit: 1791

Filing Date: December 3, 2003

Confirmation No: 4751

Title: METHOD OF MANUFACTURING MICRONEEDLE STRUCTURES USING SOFT LITHOGRAPHY AND PHOTOLITHOGRAPHY

AMENDMENT UNDER 37 CFR 1.111
AND REQUEST FOR EXTENSION OF TIME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Non-Final Office Action mailed from the PTO on March 17, 2009 for which a response was due on June 17, 2009. A two-month extension of time is requested extending the due date to August 17, 2009, and the fee therefore accompanies this response. Accordingly this response is timely filed.

Reconsideration and allowance of the pending claims, as amended, in light of the remarks presented herein are respectfully requested.

Listing of the Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.